

METHOD FOR FORMING A DEEP TRENCH CAPACITOR BURIED
PLATE

Appl. No. : 10/605,234 Confirmation No. 3393

Applicant : Chih-Han Chang,
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TC/A.U. : 2823
Examiner : NGUYEN, KHIEM D
Docket No. : NTCP0004USA
Customer No. : 27765

Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

Subject: Request for Continued Examination (RCE) in response to
the final Office Action mailed 11/22/2004

INTRODUCTORY COMMENTS

In response to the final Office action identified above, a request for continued examination (RCE) is made and the above-identified application is to be amended as indicated in the following sections. No new matter has been introduced by these amendments. A continued examination and consideration of all amendments are politely requested.